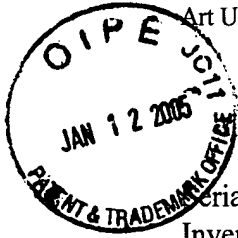


Serial Nr.: 10/695,106  
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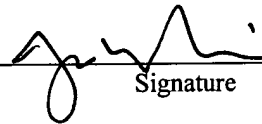


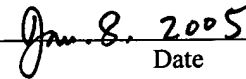
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: **10/695,106** Examiner: **Phuc T. Dang**  
Inventor: **Hong Hocheng and Yun-Liang Huang**  
Filed: **October 27, 2003** Art Unit: **2818**  
Title: **A Method For Detecting The Endpoint Of A Chemical Mechanical Polishing (CMP) Process**

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Issue Fee, Formal Drawings, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

  
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Signature

  
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Date

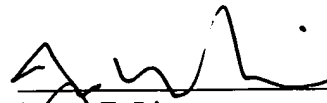
SUBMISSION OF FORMAL DRAWINGS

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Attn.: Official Draftsperson

Sir:

Enclosed are **six** sheets of the formal drawings for FIGs. **1-6** for correcting informalities and filing in the above-identified U.S. patent application.

Respectfully submitted,

  
\_\_\_\_\_  
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